

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Hongyong Zhang	Art Unit :	2814
Serial No. :	09/362,808	Examiner :	Shrinivas H. Rao
Filed :	July 28, 1999	Conf. No. :	7320
Title :	METHOD OF FABRICATING SEMICONDUCTOR DEVICE		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING RCE

Please amend the application as indicated on the following pages:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.